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Editors: Carlos J. Martinez, Amit Goyal, Alberto Saiani, David Gracias and Rajesh R. Naik

Index

[More information](#)

AUTHOR INDEX

- Adhikary, S., 101
 An, Yoo-Jin, 75
 Aoki, Yoshiya, 209
 Atanassov, Plamen B., 33
 Azam, Anum, 81
- Babeau Garcia, Annick, 177
 Backov, Rénal, 177
 Bagnall, Darren M., 163
 Barboiu, Mihail, 235
 Barrero, A., 9
 Becker, Udo, 171
 Blum, Michelle M., 183
 Boden, Stuart A., 163
 Brun, Nicolas, 177
 Buehler, Markus J., 195
- Carroll, Nick J., 33
 Chakrabarti, S., 101
 Chang, Feng-Chih, 119
 Chang, Jeng-Shian, 3
 Chao, Sheng D., 3
 Chen, Shih-Chien, 119
 Chen, Yu Jie, 89
 Chopra, Nitin, 215
 Cohen, Alan, 195
 Crews, Kristy, 215
- Deleuze, Hervé, 177
 Dorjpalam, Enkhtuvshin, 69
- Fernández-Nieves, A., 9
 Franzen, Stefan, 189
- Ghosh, K., 101
 Goddard III, William A., 195
 Gough, Julie E., 221
 Gracias, David H., 81, 153
 Grapes, Michael, 153
 Guilbaud, Jean-Baptiste, 127
- He, San Xiong, 89
- Heilshorn, Sarah C., 57, 133
 Hess, Peter, 113
 Higuera, F.J., 21
 Honda, Ryuichi, 201
 Hu, Qiaona, 171
 Huang, Kuan-Rong, 3
- Ionov, Leonid, 147
 Isaacson, Brian, 153
- Jeng, U-Ser, 119
 Jeon, Jangbae, 107
 Jiao, Jian, 95
 Johnsson, Kai, 227
- Kalinin, Yevgeniy V., 81
 Kim, M.J., 107
 Kim, Nam-Jung, 95
 Konishi, Yasuhiro, 201
 Kumar, Kamlesh, 147
 Kuo, Shiao-Wei, 119
 Kwon, Jae Wan, 95
- Laflin, Kate E., 153
 Lee, Ji Seok, 133
 Lee, Sang Ho, 107
 Lee, Sang Hoon, 107
 Leech, Patrick W., 51
 Leng, Felicity, 221
 Leonard, Donovan, 189
 Lingenfelder, Dominic, 113
 Lopez, Ciana, 33
 Loscertales, I.G., 9
 Luan, Li Xing, 89
 Luchnikov, Valeriy, 147
 Lutolf, Matthias P., 227
- Maeda, Hideaki, 69
 Maenosono, Shinya, 209
 Marín, A.G., 9
 Miller, Aline F., 127
 Mo, Alexander H., 57

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Editors: Carlos J. Martinez, Amit Goyal, Alberto Saiani, David Gracias and Rajesh R. Naik

Index

[More information](#)

- Morris, Christopher J., 153
 Mosiewicz, Katarzyna A., 227
 Mott, Derrick, 209
 Mulyasasmita, Widya, 133
 Murphy, Michael C., 45

 Nakamura, Hiroyuki, 69
 Nandan, Bhanu, 147
 Nelson, Bradley J., 141
 Nikitopoulos, Dimitris E., 45

 Oestreicher, Victor, 177
 Ogi, Takashi, 201
 Ortiz, Amber, 33
 Ovaert, Timothy C., 183

 Parisi-Amon, Andreina, 133
 Park, Hyun, 75
 Park, Taehyun, 45
 Persheyev, S.K., 63
 Petsev, Dimiter N., 33
 Prunici, Pavel, 113
 Pu, Wei Guang, 89
 Pylypenko, Svitlana, 33

 Randall, Christina L., 81
 Rani, Sudheer D., 45
 Riboux, G., 9
 Rose, M.J., 63

 Saiani, Alberto, 127
 Saito, Norizo, 201
 Salingue, Nils, 113

 Sanchez, Clément, 177
 Sen, Dipanjan, 195
 Shi, Wenwu, 215
 Soper, Steven A., 45
 Stamm, Manfred, 147
 Stavroulakis, Petros I., 163
 Su, Chun-Jen, 119

 Tamaoki, Koshiro, 201
 Thompson, Aidan P., 195
 Thuy, Nguyen T.B., 209

 Uehara, Masato, 69

 van Duin, Adri C.T., 195

 Webb, Simon J., 221
 Weitz, David A., 33
 Wong Po Foo, Cheryl, 133
 Wu, Kuang-Chong, 3
 Wu, Wei, 89

 Yamashita, Kenichi, 69
 Yang, Sung Yun, 75
 Yonemoto, Bryan T., 33
 You, Byong Hee, 45

 Zakharchenko, Svetlana, 147
 Zhang, Jiaming, 171
 Zhang, Li, 141
 Zhang, Xiaoqing, 51
 Zhu, Yonggang, 51

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Device Integration: Materials Research Society Symposium Proceedings: Volume 1272

Editors: Carlos J. Martinez, Amit Goyal, Alberto Saiani, David Gracias and Rajesh R. Naik

Index

[More information](#)

SUBJECT INDEX

- actuator, 141
- Ag, 209
- alloy, 153
- Au, 209
- biological, 57
 - synthesis (assembly), 45, 189
 - synthesis (chemical reaction), 201
- biomaterial, 63, 127, 133, 171, 195, 221, 227, 235
- biomedical, 57, 81
- biomimetic
 - (assembly), 133, 163, 183, 221
 - (chemical reaction), 227
- blend, 119
- catalytic, 177, 201
- cellular (material form), 75
- chemical synthesis, 89
- colloid, 69
- composite, 95
- core/shell, 209
- crystal growth, 171
- crystallographic structure, 171
- devices, 57
- elastic properties, 51
- electrical properties, 89
- electron energy loss spectroscopy (EELS), 189
- epitaxy, 101
- fiber, 127
- fluid, 9, 21, 45
- fluidics, 9, 21, 45
- foam, 177
- fracture, 195
- hot pressing, 51
- III-V, 101
- infrared (IR) spectroscopy, 113
- kinetics, 3
- liquid, 9
- lithography (deposition), 63
- lubricant, 183
- magnetic, 153
 - properties, 221
- microelectro-mechanical (MEMS), 63, 75, 81, 141
- molecular beam epitaxy (MBE), 101
- morphology, 89, 107
- nanostructure, 95, 215
- optical properties, 163
- organic, 235
- oxide, 215
- particulate, 33
- pd, 189, 201
- phase transformation, 69
- polymer, 51, 119, 133, 147, 183, 215
- polymerization, 227
- porosity, 33
- self-assembly, 75, 81, 95, 107, 119, 153, 163, 235
- si, 195
- simulation, 3, 21
- sol-gel, 33, 127, 177
- solution deposition, 69
- stress/strain relationship, 107
- surface, 147
 - chemistry, 113
- thermoelectric, 3
- thin film, 141, 147
- x-ray photoelectron spectroscopy (XPS), 113